Docket No.: 2336-179 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
SEO, Dong Hwan et al.	:	•
U.S. Patent Application No	:	Group Art Unit:
Filed: June 24, 2003	:	Examiner:

For:

LOW TEMPERATURE SINTERABLE DIELECTRIC CERAMIC COMPOSITION,

MULTILAYER CERAMIC CHIP CAPACITOR AND CERAMIC ELECTRONIC

**DEVICE** 

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

LOWE HAUPTMAN GILMAN & BERNER, LLP

Benjamin J. Hauptman Registration No. 29,310

1700 Diagonal Road, Suite 300 Alexandria, Virginia 22314 (703) 684-1111 BJH/klb Facsimile: (703) 518-5499

Date: June 24, 2003

## ATTY. DOCKET NO. U.S. PATENT 2336-179 APPLICATION NO. INFORMATION DISCLOSURE -----CITATION IN AN **APPLICANT** APPLICATION SEO, Dong Hwan et al. FILING DATE **GROUP** (PTO-1449) June 24, 2003 U.S. PATENT DOCUMENTS FILING **EXAMINER'S** CLASS PATENT NO. DATE NAME **SUBCLASS** INITIALS DATE 5,756,408 05/1998 Terashi et al. 01/1991 Nishioka et al. 4,988,651 FOREIGN PATENT DOCUMENTS Translation **EXAMINER'S** DATE COUNTRY **CLASS SUBCLASS** PATENT NO. **INITIALS**

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Abstract – Japanese Patent No. JP5190020, Published July 30, 2003

Abstract – Japanese Patent No. JP1102806, Published April 20, 1989

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.